Shower shape studies with EMC

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Outline

- PID with EMC
- Parameters for PID
- Multivariate analysis for PID
- Validation studies for EMC
- Summary

PID with EMC

- PID parameters e/p, z20, E4, #bumps, E9E25...
 - Number of parameters
- PID separation high momentum pi0, γ

pi0 - Y separation

- Bump splitting
- Invariant mass
- lateral moment
- shower shape
- MVA



Z20 for pi0 - Y



Shower spread-E4





Shower spread-E4 pi0 - Y



Christian Geldmann

Shower shape-correlation



Multivariate analysis

Multivariate analysis is important for understanding the structure of correlated parameters

- KNN large data set, very slow
- LVQ Sensitive to training data, Fast
- Neural Network parameterizing the boundary, slow



MVA analysis for pi0 - Y separation



pi0 - Y Separation



Elwin Dijck

MVA provides optimum identification of particles from a highly correlated parameters

MVA Tools

- KNN, LVQ developed for PANDA by Mohammad Babai
- PndPidAssociator Global PID
- PndPidEmcAssociator EMC PID
- trunk/PndTools/MVA/macros
- note rely training data set

Validation study





Experiment Simulation Test Experiment of PWO crystals with photons 150 MeV -1500 MeV in Mainz - Useful for validation

Cosmic calibration

PWO Stopping power 10.2 MeV/cm



Background Cosmic muon

Geometry

PWO Crystal Geometry - Trapezoid Front face ~ 21 x 21 mm² Back face ~ 27 x 27 mm²

Carbon – Alveoles Thickness 200 micron reflector Thickness 65 micron coolant cover I mm Copper I mm Aluminum



Prototype central crystal response



Geant3 Data 100keV cut No digitalization

non-linear energy response

Ringl





Ring2



- Observations Simulation Data
 - Non-linear energy response
 - Different lateral shower profile
- How to tune the simulation
 - Optimizing cuts in the transport model
 - Optical light response
 - Light yield along Z Christian Hammann
 - New data

Ecen vs Geant3 cut

cut - lowest energy below which particle will not be tracked





- Though energy response is sensitive to the Geant3 cut, non-linearity in the central crystal can not be reproduced.
- Lowering geant3 cut will diffuse the energy to the outer ring and match with the data in outer shower.
- Geant4 energy response is not sensitive to the cut.

Summary

- Parameters identified for PID- E/p,E4,Z20
- MVA is important for extraction of de correlated information from parameters
- MVA tools are available in PANDA-root
- Validation of shower shape against data is ongoing. Cut, noise parameters are inconclusive
- Acceptance Studies of optical photon is in progress